

5 forming the passivation film consisting of chromium oxide by applying heat treatment in an oxidizing atmosphere after coating chromium on the metallic material of [which] the surface roughness (Ra) of [a coat] metallic material surface is not more than [1.5im] 1.5 $\mu$ m.

4. (Amended) [Parts contracting with fluid and a] A fluid supplying/exhaust system for manufacturing semiconductors, comprising metallic material having a chromium-oxide passivation film according to claim 1.

IN THE ABSTRACT

Please delete the abstract on file and replace it with the attached ABSTRACT OF THE DISCLOSURE.

If the Examiner has any questions or comments that would speed prosecution of this case, he is invited to call the undersigned at 219/485-6001.

Respectfully submitted,

  
\_\_\_\_\_  
Randall J. Knuth  
Registration No. 34,644

RJK/jrw

Encs: Clean Claims  
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ABSTRACT OF THE DISCLOSURE  
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RANDALL J. KNUTH, P.C.  
3510-A Stellhorn Road  
Fort Wayne, IN 46815-4631  
Telephone: 219/485-6001  
Facsimile: 219/486-2794

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Signature  
July 13, 2001  
Date